

# Capacitive | E09.CAP

## **Capacitive CAP Micrometer**



### Introduction

E09.Cap capacitance non-contact micrometer can measure the small displacement in the range of  $0\sim500\mu m$  through the capacitance probe, the measurement accuracy is nanometer level. The micrometer is composed of a chassis and a sensing module, which can form a multi-channel measurement.

#### Characteristics >>

- Modular design, free combine
- Single board module available
- · High resolution
- Analog output
- Non-contact measurement

#### Applications >>

- Vibration measurement
- · Precision positioning system
- Micro-displacement detection
- Position detection
- Optical fiber alignment and etc that require micro-displacement detection
- Length(depth, height, thickness, diameter, taper, etc.) measurement

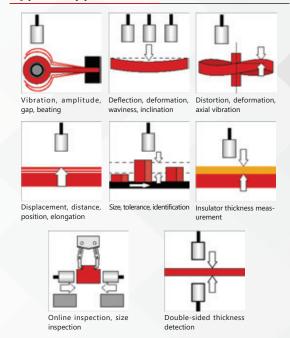




#### Technical Data >>

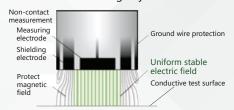
Туре	E09.CAP100	E09.CAP200	E09.CAP500	Units
Measuring range	0~100	0~200	0~500	μm
Static resolution	1.25	2.5	5	nm
Dynamic resolution(1kHz)	100			nm
Linearity	0.05			%F.S.
Repeatability	0.0025			%F.S.
Sensor diameter	10			mm
Minimum target diameter	10			mm
Signal temperature stability	< 0.005			%FSO/°C
Long-term stability	< 0.04			%FSO/month
Bandwidth	2			kHz(-3dB)
Operating temperature	+10~+50			°C
Humidity	<85			%
Voltage output	0~+10			V
Power supply	220VAC 50Hz±10%			
Sensor cable length	1.6			m
Board size: L×H×D	35×130×180			mm
Chassis size: L×H×D	280×170×360			mm

#### Typical Application >>



#### Principle >>

It is based on the principle of an ideal parallel plate capacitor. The sensor and the measured target on the opposite side form two electrodes. The principle of guard ring capacitor is used to ensure that the sensor is still linear when measuring any metal.



#### Module Combination >>



### Capacitance Probe >>

